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## APPLICANTS

Toru Mori, Miyagi, JAPAN;

\*\* CONTINUING DATA *None*\*\* FOREIGN APPLICATIONS *Yes*  
JAPAN 2003-169161 06/13/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/06/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after <i>Allowance</i>	JAPAN	11	20	2
Verified and Acknowledged	<i>[Signature]</i> <i>[Initials]</i>				

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## TITLE

Manufacturing method for SOI semiconductor device, and SOI semiconductor device

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